AMENDMENT TO THE CLAIMS:

This listing of claims will replace all prior versions of claims in the application:

LISTING OF CLAIMS:

- (ORIGINAL) A system for lapping a head, comprising:
- a wafer including at least one head each having an electrical lapping guide
 (ELG), a plurality of wafer contacts in electrical communication with the ELG,
 and a closure formed thereon defining a slot in which the wafer contacts are
 positioned;
- (b) a lapping cable coupled to a testing device, the lapping cable including a
 plurality of lapping cable contacts; and
- (c) an adapter including a plurality of adapter contacts in electrical communication with the lapping cable contacts;
- (d) wherein the adapter contacts are removably positionable in electrical communication with the wafer contacts during a lapping process.
- (ORIGINAL) The system as recited in claim 1, wherein the adapter is constructed from a polyimide material.
- (PREVIOUSLY PRESENTED) The system as recited in claim 1, wherein the
 adapter includes a pair of holes formed therein for coupling with a pair of holes
 formed in the lapping cable via a pair of alignment pins.
- 4. (ORIGINAL) The system as recited in claim 1, wherein the adapter includes at least one guide for being removably positioned in a slot defined by closures of adjacent heads formed on the wafer.

- (ORIGINAL) The system as recited in claim 1, wherein the adapter contacts are slidably coupled to the adapter.
- 6. (ORIGINAL) The system as recited in claim 1, wherein the adapter contacts each include a first portion in electrical communication with one of the lapping cable contacts and a second portion in electrical communication with one of the wafer contacts.
- (ORIGINAL) The system as recited in claim 6, wherein the first portion of each adapter contact is larger than the second portion of each adapter contact.
- (ORIGINAL) The system as recited in claim 7, wherein the first portion of each adapter contact has a diameter larger than that of the second portion of each adapter contact.
- (ORIGINAL) The system as recited in claim 6, wherein the adapter includes a
 recess for preventing contact with the wafer during the lapping process.
- 10. (WITHDRAWN) An system for lapping a head, comprising:
- (a) a wafer including at least one head each having an electrical lapping guide (ELG), a plurality of wafer contacts in electrical communication with the ELG, and a closure formed thereon defining a slot in which the wafer contacts are positioned; and
- (b) a lapping cable coupled to a testing device, the lapping cable including a
 plurality of lapping cable contacts extending outwardly therefrom;
- (c) wherein the lapping cable contacts are removably positionable in electrical communication with the wafer contacts during a lapping process.

- 11. (WITHDRAWN) The system as recited in claim 10, wherein the lapping cable includes at least one guide for being removably positioned in a slot defined by closures of adjacent heads formed on the wafer.
- (WITHDRAWN) The system as recited in claim 10, wherein the lapping cable
 contacts extend in a direction perpendicular with respect to the lapping cable.
- (WITHDRAWN) The system as recited in claim 10, wherein the lapping cable includes a recess for preventing contact with the wafer during the lapping process.
- 14. (ORIGINAL) An apparatus for use with a wafer including at least one head each having an electrical lapping guide (ELG), a plurality of wafer contacts in electrical communication with the ELG, and a closure formed thereon defining a slot in which the wafer contacts are positioned, and a lapping cable coupled to a testing device, the lapping cable including a plurality of lapping cable contacts; the apparatus comprising: an adapter including a plurality of adapter contacts in electrical communication with the lapping cable contacts, wherein the adapter contacts are removably positionable in electrical communication with the wafer contacts during a lapping process.
- 15. (WITHDRAWN) An apparatus for use with a wafer including at least one head each having an electrical lapping guide (ELG), a plurality of wafer contacts in electrical communication with the ELG, and a closure formed thereon defining a slot in which the wafer contacts are positioned, the apparatus comprising:
- a lapping cable coupled to a testing device, the lapping cable including a
 plurality of lapping cable contacts extending outwardly therefrom in direction
 perpendicular with respect to the lapping cable;
- (b) wherein the lapping cable contacts are removably positionable in electrical communication with the wafer contacts during a lapping process.

- 16. (PREVIOUSLY PRESENTED) An adapter including a plurality of adapter contacts adapted for electrical communication with a plurality of lapping cable contacts of a lapping cable, wherein the adapter contacts are removably positionable in electrical communication with a plurality of wafer contacts of a wafer during a lapping process.
- 17. (WITHDRAWN) A testing system comprising a lapping cable coupled to a testing device, the lapping cable including a plurality of lapping cable contacts extending outwardly therefrom in a direction perpendicular with respect to the lapping cable, wherein the lapping cable contacts are removably positionable in electrical communication with a plurality of wafer contacts of a wafer during a lapping process.
- 18. (PREVIOUSLY PRESENTED) An adapter including a plurality of adapter contacts in electrical communication with a plurality of lapping cable contacts of the lapping cable, the adapter further including at least one guide for being removably positioned in a slot defined by closures of adjacent heads formed on the wafer, and a recess for preventing contact with the wafer during the lapping process, wherein the adapter contacts are removably positionable in electrical communication with a plurality of wafer contacts of the wafer during a lapping process.
- 19. (WITHDRAWN) A method for testing during a lapping process, comprising:
- (a) providing an adapter including a plurality of adapter contacts in electrical communication with a plurality of lapping cable contacts of the lapping cable;
- removably positioning the adapter contacts of the adapter in electrical communication with a plurality of wafer contacts of a wafer;
- (c) lapping a surface of the wafer; and
- (d) measuring a head of the wafer during the lapping process.

- 20. (PREVIOUSLY PRESENTED) A system for lapping a head, comprising:
- (a) a lapping cable coupled to a testing device, the lapping cable including a plurality of lapping cable contacts; and
- (b) an adapter including a plurality of adapter contacts in electrical communication with the lapping cable contacts;
- (c) wherein the adapter contacts are removably positionable in electrical communication with contacts on a wafer during a lapping process.